



PATENT
Atty. Dkt. AMAT/8657/DISPLAY/AKT/RKK

IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Choi, et al.

Serial No.: 10/823,347

Filed: April 12, 2004

Confirmation No.: 4736

For: Gas Diffusion Shower
Head Design For Large
Area Plasma Enhanced
Chemical Vapor Deposition

§ Group Art Unit: 1724

§ Examiner: Unknown

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING
37 CFR 1.8

I hereby certify that this correspondence is being deposited on
March 30, 2005 with the United States Postal Service as First
Class Mail in an envelope addressed to: Commissioner for
Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

3/30/05
Date

Karen Zaleski
Signature

PRELIMINARY AMENDMENT

Prior to examination, please amend the above-identified application as follows.
Amendments to the Specification begin on page 2 of this paper. **Amendments to the Claims** are reflected in the listing of claims which begins on page 11 of this paper. **Amendments to the Drawings** begin on page 23 of this paper and include both an attached replacement sheet and an annotated sheet showing changes. **Remarks** begin on page 24 of this paper.